

Docket No.: 55071-280

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Jang Fung CHEN, et al.	:	Confirmation Number:
	:	
Serial No.: Continuation of Appl. No. 09/840,291	:	Group Art Unit:
	:	
Filed: September 16, 2003	:	Examiner:
	:	
For: HYBRID PHASE-SHIFT MASK	:	

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The references were cited by or submitted to the U.S. Patent and Trademark Office in parent application Serial No. 09/840,291, filed April 24, 2001, which is relied upon for an

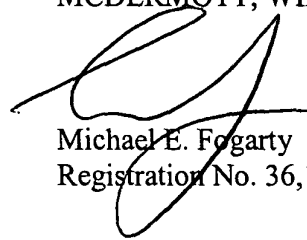
09/840,291

earlier filing date under 35 USC 120. Thus, copies of these references are not attached. 37 CFR 1.98(d).

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

A handwritten signature in black ink, appearing to read "Michael E. Fogarty", is written over the printed name and registration number.

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**Date: September 16, 2003**

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>55071-280</b>		SERIAL NO. <b>C ntinuati n of Appl. N . 09/840,291</b>	
				APPLICANT <b>Jang Fung CHEN, et al.</b>			
				FILING DATE <b>September 16, 2003</b>		GROUP	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US 5,424,154	6/95	Borodovsky			
		US 5,827,623	10/98	Ishida et al.			
		US 6,114,071	9/00	Chen et al.			
		US 5,821,014	10/13/98	Chen et al.			
		US 5,723,233	03/03/98	Garza et al.			
		US 5,663,893	09/02/97	Wampler et al.			
		US 5,707,765	01/13/98	Chen			
		US 5,538,815	07/23/96	Oi et al.			
		US 5,447,810	09/05/95	Chen et al.			
		US 5,436,095	07/25/95	Mizuno et al.			
		US 5,362,584	11/08/94	Brock et al.			
		US 5,324,600	06/28/94	Jinbo et al.			
		US 5,288,569	02/22/94	Lin			
		US 5,256,505	10/26/93	Chen et al.			
		US 5,242,770	09/07/93	Chen et al.			
		US 5,229,255	07/20/93	White			
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Code <sup>1</sup> -Number + -Kind Codes (if known)	Publication Date M of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation		
					Yes	No	
		EP 1 122 603	08/08/01				
		99/47981	09/23/99				
		EP 0 620 498	10/19/94				
		JP-11223930	08/17/1999				
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
		Fourmun Lee and Tom Zirkle, "Process for Hybrid Phase-Shifting Mask Fabrication," 03/01/93, pages 1-2.					
EXAMINER				DATE CONSIDERED			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

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		Number-Kind Code <sup>2</sup> (if known)							
		US	5,882,827	03/16/99	Nakao				
		US	5,362,591	11/08/94	Imai, et al.				
		US	5,858,580	01/12/99	Wang, et al.				
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		US	5,821,014	10/13/1998	Chen et al.				
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		US	6,258,493	07/2001	Wang et al.				
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								Yes	No
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